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Overview

High temperature heat transfer is an interaction between matter and a radiation field. The radiation field heats the material and moves energy through photon streaming and scatter. The material conducts energy and emits radiation proportional to T^4 . Coupled radiation and material heat conduction is important in:

- NIF shots
- Glass cooling
- Astrophysics

The thermal radiative transfer equations

• 1D, frequency-integrated (grey) equations

$$\frac{1}{c}\frac{\partial I}{\partial t} + \mu \frac{\partial I}{\partial x} + \sigma_t I = \frac{\sigma_s}{2}\phi + \frac{1}{2}\sigma_a acT^4$$
 (1)

$$C_{\nu} \frac{\partial T}{\partial t} = \sigma_{a} \phi - \sigma_{a} a c T^{4}. \tag{2}$$

$$\phi(x) = \int_{-1}^{1} I(x, \mu) \mathrm{d}\mu \tag{3}$$

- \bullet Cross sections (σ) can be a strong function of T
- Tightly coupled and contain non-linear Planckian emission source $\sigma_a a c T^4$

The implicit Monte Carlo method

- These equations are typically solved with MC via the Implicit Monte Carlo (IMC) method
- In IMC, the material energy equation is linearized over a time step and eliminated from the system
- Results in an effective source and scattering cross section for a linear transport problem
- Drawbacks
 - Effective scattering cross section can be very large
 - System is not truly implicit, because of linearization

A High-Order Low-Order Solution

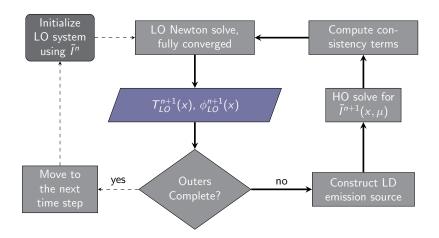
Basic Idea

Build a low-order (LO) system that can be efficiently solved, with high-order (HO) correction from simpler MC simulations

- Useful when global solution of particle density needed
- The LO solution preserves the HO solution, upon convergence (giving consistency)
- The LO solver resolves non-linear temperature dependence
 - Produces a linear-discontinuous (LD) finite element representation of sources
 - Lower dimensional problem in anglular variable
- The HO system is a fixed-source, pure-absorber transport problem
 - ECMC allows for the statistical noise to be reduced globally. giving accurate consistency terms

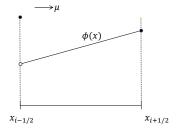
High-Order Low-Order Algorithm

Introduction

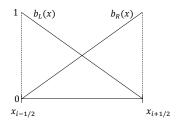


LO Discretization & Space-Angle Moments

 Linear Discontinuous (LD) finite elements in space and half range angular integrals



$$\langle \cdot \rangle_{L,i} = \frac{ \frac{\text{Spatial moments}}{2}}{h_i} \int_{x_{i-1/2}}^{x_{i+1/2}} b_{L,i}(x)(\cdot) \mathrm{d}x \qquad \qquad \frac{\text{Angular half-ranges}}{\phi^+(x) = 2\pi \int_0^1 I(x,\mu) \mathrm{d}\mu}$$



Angular half-ranges
$$\phi^{+}(x) = 2\pi \int_{0}^{1} I(x, \mu) d\mu$$

• Taking moments of TE yields 4 equations, per cell i, e.g.

$$-2\mu_{i-1/2}^{+}\phi_{i-1/2}^{+} + \langle \mu \rangle_{L,i}^{+} \langle \phi \rangle_{L,i}^{+} + \langle \mu \rangle_{R,i}^{+} \langle \phi \rangle_{R,i}^{+} +$$

$$\Sigma_{t}h_{i}\langle \phi \rangle_{L,i}^{+} - \frac{\Sigma_{s}h_{i}}{4\pi} \left(\langle \phi \rangle_{L,i}^{+} + \langle \phi \rangle_{L,i}^{-} \right) = \frac{1}{k_{\text{eff}}} \frac{\nu \Sigma_{f}h_{i}}{4\pi} \langle \phi \rangle_{L,i}^{+}$$

High-Order Low-Order Algorithm

- Cell unknowns: $\langle \phi \rangle_{Li}^+$, $\langle \phi \rangle_{Ri}^+$, $\langle \phi \rangle_{Li}^-$, $\langle \phi \rangle_{Ri}^-$
- Need angular consistency terms and spatial closure (LD)

Computing LO Consistency terms from HO Solution

• For $\mu > 0$, L moment

$$\langle \mu \rangle_{L,i}^{+} \simeq \frac{\frac{2}{h_{i}} \int_{0}^{1} \int_{x_{i-1/2}}^{x_{i+1/2}} \mu \, b_{L,i}(x) \tilde{\psi}^{HO}(x,\mu) d\mu dx}{\frac{2}{h_{i}} \int_{0}^{1} \int_{x_{i-1/2}}^{x_{i+1/2}} b_{L,i}(x) \tilde{\psi}^{HO}(x,\mu) d\mu dx}$$
(4)

- ECMC gives LDFE $\tilde{\psi}^{HO}(x,\mu)$ for computing terms directly
- To get S₂, set $\langle \mu \rangle^{\pm} = \pm \frac{1}{\sqrt{3}}$

Solving LO System with Power Iteration

Global System:

$$\mathbf{D}\Phi = \frac{1}{k_{\mathsf{eff}}}\mathbf{F}\Phi$$

High-Order Low-Order Algorithm

Algorithm

Introduction

• Guess $\Phi^{(0)}$ and $k_{\text{eff}}^{(0)}$

$$\begin{split} \boldsymbol{\Phi}^{(l+1)} &= \frac{1}{k_{\mathrm{eff}}^{(l)}} \mathbf{D}^{-1} \mathbf{F} \boldsymbol{\Phi}^{(l)} \\ k_{\mathrm{eff}}^{(l+1)} &= k_{\mathrm{eff}}^{(l)} \frac{\int \nu \Sigma_f \phi^{(l+1)} \mathrm{d}x}{\int \nu \Sigma_f \phi^{(l)} \mathrm{d}x}. \end{split}$$

$$k_{\mathsf{eff}}^{(I+1)} = k_{\mathsf{eff}}^{(I)} \frac{\int \nu \Sigma_f \phi^{(I+1)} \mathsf{d}x}{\int \nu \Sigma_f \phi^{(I)} \mathsf{d}x}$$

- **2** Converge $\phi(x)$ and k_{eff}
- **3** Accelerate $\Phi^{(l)}$ and $k_{\text{eff}}^{(l+1)}$ after each power iteration with Nonlinear Krylov Acceleration (NKA)

Exponentially Convergent Monte Carlo

- An iterative form of residual Monte Carlo
- Requires a functional form of the angular flux in space and angle
 - Use finite element representation
- Can reduce statistical error globally $\propto e^{-\alpha N}$
 - Does not make difficult problems easier
- Adaptive mesh refinement allows the error to continue to be reduced
 - Increase N per batch by factor of new cells added

High-Order Solver

$$\psi_{j+1/2}$$
• $\tilde{\psi}(x,\mu) = \psi_{a,i} + \psi_{x,i} \frac{2}{h_x} (x-x_i) + \psi_{\mu,i} \frac{2}{h_\mu} (\mu-\mu_i)$
• Path-length estimators of moments, e.g.
$$\psi_{x,i} = \frac{6}{h_x^2 h_\mu} \iint_{\mathcal{D}} (x_{c,j} - x_i) \psi(x, mu) dx d\mu$$

- Particles are allowed to stream, $w(s) = w_0 e^{-\sum_t s}$
- LDFE and upwinding eliminates surface tallies
- Cell-wise, global representation allows for stratified sampling
 - $N_{i,i} \propto |r_i(x,\mu)|$
 - Force $N_i \geq N_{\min}$ and adjust particle weights

High Order System and ECMC Algorithm

• Pure absorber transport problem

$$\left[\mu \frac{\partial}{\partial x} + \Sigma_t\right] \psi(x, \mu) = \boxed{\frac{1}{4\pi} \left(\Sigma_s + \frac{1}{k_{\text{eff}}^{LO}}\right) \phi^{LO}(x)}$$

$$\mathbf{L}\psi = q^{LO}$$

ECMC Algorithm

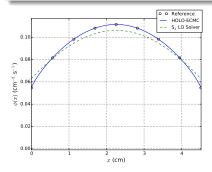
- Residual Equation: $\mathbf{L}\tilde{\epsilon}^{(m)} = \tilde{r}^{(m)} = q^{LO} \mathbf{L}\tilde{\psi}^{(m)}$
- Compute $\tilde{\epsilon}^{(m)} = \mathbf{L}^{-1}\tilde{r}^{(m)}$ with MC, projecting the solution
- Update: $\tilde{\psi}^{(m)} = \tilde{\psi}^{(m-1)} + \tilde{\epsilon}^{(m)}$
 - ullet If $ilde{\epsilon}$ is reduced each batch, exponential convergence achieved
 - h-refine when $\epsilon(x,\mu)$ not represented sufficiently
 - Must sufficiently reduce noise in ϵ tallies, each batch
- Repeat until $\|\tilde{\epsilon}\|_2 < \operatorname{tol} \times \|\psi\|_2$

Critical slab benchmark

Introduction

Problem Parameters

- $k_{\infty} = 2.29$, $\Sigma_t = 0.326$ cm⁻¹
- 2.4×10^5 histories per batch, $100 \times \& 20 \mu$ cells
- Adaptive HO convergence

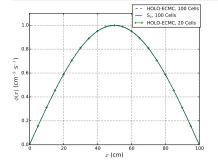


- $|\Delta \Phi| < 10^{-4}$ in 4 outer iterations, using $\sim 2.4 \times 10^7$ histories
- For 10 independent simulations:
 - $\overline{k_{
 m eff}} = 0.999998, \ \sigma(k_{
 m eff}) = 4.1 imes 10^{-6}, \ {
 m max dev.} = 1.1 imes 10^{-5}$
 - $\overline{\sigma_{\rm rel}(\phi_i)} = 1.4 \times 10^{-05}$

Optically thick, near-critical slab

Problem Parameters

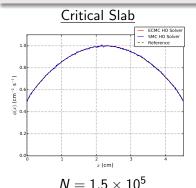
- $k_{\infty} = 1$, $\Sigma_t = 30.0 \text{ cm}^{-1}$, $\Sigma_s = 29.5 \text{ cm}^{-1}$, DR $\simeq 0.999$
- Relative Tolerance of 1.0E-05 for all solvers

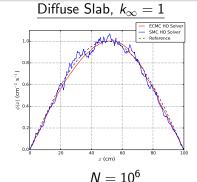


- Fission source convergence:
 - Power iteration not. converged after 10,000 iterations
 - NKA converged in 246 iterations
- 1 outer iteration, 4.8×10⁶ total histories
- $k_{\rm eff} = 0.99997$

Comparison of statistical noise for standard and ECMC HO solvers

• One HO solve, with a fixed number of histories N. Comparison of ECMC with 5 batches or standard MC (SMC)





High-Order Low-Order Algorithm

Current & Future Development

- Can Solve for k_{eff} and fission source with HOLO method
 - Pure absorber histories are cheaper than standard MC simulations
 - ECMC efficiently reduces noise globally
 - LO solver handles scattering, fission, and
- Stratified source sampling more efficient at reducing statistical variance than a constant number of particles per cell
- Need to use the estimated statistical error in tallies for $\tilde{\epsilon}(x,\mu)$

Questions?

Introduction

A High-Order Low-Order Algorithm with Exponentially-Convergent Monte Carlo for Thermal Radiative Transfer

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Backup Slides





ECMC procedure

Algorithm

- **2** Using Monte Carlo, solve $\epsilon^{(m)} = \mathbf{L}^{-1} \tilde{r}^{(m)}$
 - Use volumetric tallies, weighted with x and μ basis moments time ψ to construct LD $\tilde{\epsilon}^{(m)}(x,\mu)$ over the current space-angle mesh
- $\tilde{\psi}^{(j+1)} = \tilde{\psi}^{(m)} + \tilde{\epsilon}^{(m)}$
- IF error stagnation:
 - ullet Refine mesh based on relative jump error in $ilde{\psi}(x,\mu)$
- **5** Repeat 2-4 until $\|\tilde{\epsilon}\|_2 < \text{tol} \times \|\psi\|_2$

HOLO Algorithm

Algorithm

- Initialize $\langle \mu \rangle^{\pm}$ parameters to S_2
- Solve LO system using power iteration
- Solve $\tilde{\psi}(x,\mu) = \mathbf{L}^{-1}q^{LO}$ using ECMC
- $\ \, \bullet \,$ Compute new $\langle \mu \rangle^{\pm}$ parameters using $\tilde{\psi}^{HO}$ over LO mesh
- **6** Repeat 2-5 until Φ^{LO} is converged
- Use adaptive convergence criteria

Exponential Convergence Plot